

Atmos. Meas. Tech. Discuss., 2, C1445–C1445,
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AMTD

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Interactive
Comment

Interactive comment on “Measurement of ozone production sensor” by M. Cazorla and W. H. Brune

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The Teflon film used for the chambers is of the type FEP. In the manuscript we wrote PTFE by mistake. We have changed this term in the manuscript.

Interactive comment on Atmos. Meas. Tech. Discuss., 2, 3339, 2009.

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Interactive Discussion

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